IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Aref Ben Ahmed Jallouli et al.

Serial No.: 09/992,054

Filed: November 14, 2001

For: HIGH INDEX AND HIGH IMPACT

RESISTANT

POLYTHIOURETHANE/UREA MATERIAL, METHOD OF

MANUFACTURING SAME AND ITS

USE IN THE OPTICAL FIELD

Group Art Unit: 1711

Examiner: Rabon A. Sergent

Atty. Dkt. No.: ESSR:058US

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 223187

1450, on the date below:

December 19, 2003

Date

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

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In accordance with 37 C.F.R §§ 1.97(g), (h), this Supplemental Information Disclosure

Statement is not to be construed as a representation that a search has been made, and is not to be

construed to be an admission that the information cited is, or is considered to be, material to

patentability as defined in 37 C.F.R. § 1.56(b).

A fee as set forth in 37 C.F.R. § 1.17(p) in the amount of \$180.00 is enclosed herewith.

If an appropriate check has not been enclosed, or if it is insufficient, the Commissioner is

authorized to deduct the appropriate fee from Fulbright & Jaworski Account No.: 50-

1212/ESSR:058US.

Applicants respectfully request that the listed documents be made of record in the present

case.

Respectfully submitted

Mark B. Wilson Reg. No. 37,259

Attorney for Applicants

FULBRIGHT & JAWORSKI L.L.P. 600 Congress Avenue, Suite 2400 Austin, Texas 78701 (512) 474-5201

Date:

December 19, 2003

Form P	TO-1449	(modified)		1 -	Atty. Docket No.		Serial N .		
				ESSR:058US	ESSR:058US		09/992,054		
List of P	atents an	d Publications for	Applicant's	Applicant	Applicant				
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	B2	WO 01/36508	11/18/00	PCT					
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